

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of '

Akihisa HONGO et al.

Docket No. 2001_0133A

Serial No. 09/762,582

Group Art Unit 1741

Filed April 12, 2001

SUBSTRATE PLATING METHOD AND APPARATUS

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TO 1700

SUBMISSION OF ENGLISH VERSION OF IPER

Assistant Commissioner for Patents, Washington, D.C.

Sir:

An English language version of the International Preliminary Examination Report is submitted herewith for the Examiner's consideration.

Respectfully submitted,

Akihisa HONGO et al.

By:_

Michael S. Huppert Registration No. 40,268 Attorney for Applicants

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